



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Teruo TAKIZAWA

Group Art Unit: 2826

Application No.: 10/785,073

Examiner: K. QUINTO

Filed: February 25, 2004

Docket No.: 118439

For: SEMICONDUCTOR DEVICE INCLUDING P-TYPE SILICON LAYER INCLUDING
IMPLATED GERMANIUM

SUBMISSION OF REFERENCES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please place the attached document in the Patent Office file for the above-identified matter. Listed below is a Japanese reference that became known to Applicant no later than November 13, 2007 in connection with this application.

- 1 JP A 2002-076111
March 15, 2002
Japan

Respectfully submitted,

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JAO:TJB/mab

Attachment:

Japanese Application No. 2002-076111

Date: December 4, 2007

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